INFORMATION DISCLOSURE CITATION					Docket Number (Optional) OKI.298 Applicant(s)		Application Number	r C NEW E	76 TO
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Form PTO-A820 (also form PTO-1449)

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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. (Under 37 CFR 1.97(b) or 1.97(c)) OKI.298 In Re Application: Hirokazu HAYASHI Serial No. Filing Date Examiner Group Art Unit **NEW** JAN. 24, 2002 TO BE ASSIGNED TO BE ASSIGNED METHOD FOR MODELING SEMICONDUCTOR DEVICE PROCESS Payment of Fee (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) □ A check in the amount of is attached. ☐ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. as described below. A duplicate copy of this sheet is enclosed. Charge the amount of Credit any overpayment. Charge any additional fee required. Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail I certify that this document and authorization to charge deposit I certify that this document and fee is being deposited account is being facsimile transmitted to the United States with the U.S. Postal Service Patent and Trademark Office (F as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231. (Date) Signature Signature of Person Mailing Correspondence Typed or Printed Name of Person Signing Certificate Typed or Printed Name of Person Mailing Certificate *This certificate may only be used if paying by deposit account. Dated: JAN. 31, 2002 Signature ADAM C. VOLENTINE **REG. NO. 33289 VOLENTINE FRANCOS, PLLC** 12200 SUNRISE VALLEY DRIVE, SUITE 150 **RESTON, VA 20191** TEL. NO. (703) 715-0870 CC:

TRANSMITTAL O	Docket No. OKI.298										
In Re Application Of:	Hirokazu HAYASHI		c971 U.								
Serial No.	Filing Date	Examiner	Group Art Unit								
NEW	JAN. 31, 2002	TO BE ASSIGNED	TO BE ASSIGNED								
Title: METHOD FOR M	MODELING SEMICONDUCTOR										
	Address to: Assistant Commissioner for Patents Washington, D.C. 20231										
	37 C	FR 1.97(b)									
1. A The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114. 37 CFR 1.97(c)											
CFR 1.97(b), pr Final Action und											
☐ the staten	☐ the statement specified in 37 CFR 1.97(e);										
OR											
☐ the fee se	et forth in 37 CFR 1.17(p).										